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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatoshi TSUCHIYA et al.

Group Art Unit: 2853

Application No.: 10/721,353

Examiner: L. MARTIN

Filed: November 26, 2003

Docket No.: 117059

For: SYSTEMS AND METHODS FOR VENT PATH LEAKAGE PREVENTION

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the July 28, 2006 Office Action and the October 12 personal interview,
please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.